

2834  
TFU

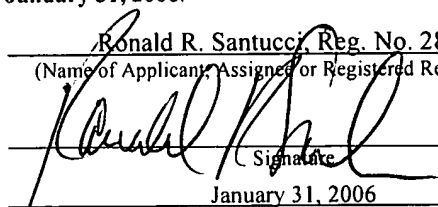
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Tetsuo YAMADA, et al.  
Serial No. : 10/518,704  
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN  
FILM PIEZOELECTRIC DEVICE, AND  
MANUFACTURING METHOD THEREOF (As Amended)  
Filing Date : December 17, 2004  
Examiner : Not Yet Assigned  
Group Art Unit : 2834  
Confirmation No. : 5674

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Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on  
January 31, 2006.

Ronald R. Santucci, Reg. No. 28,988  
(Name of Applicant, Assignee or Registered Representative)

  
Signature  
January 31, 2006  
Date of Signature

**THIRD PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the examination of the above-referenced patent application,

Applicants respectfully request that the application be further amended as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page 2 of this paper.

**Remarks** begin on page 13 of this paper.